

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT		
NATURE OF CONVEYANCE:	LICENSE		
CONVEYING PARTY DATA			
Name			Execution Date
INNOVATECH, LLC			06/09/2009
RECEIVING PARTY DATA			
Name:	ORION INDUSTRIES, LTD.		
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PROPERTY NUMBERS Total: 2			
Property Type	Number		
Application Number:	14444603		
Application Number:	15486012		
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ATTORNEY DOCKET NUMBER:	025099-0071		
NAME OF SUBMITTER:	HOLBY M. ABERN		
SIGNATURE:	/Holby M. Abern/		
DATE SIGNED:	04/13/2017		
Total Attachments: 3			
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source=025099-0071-License#page3.tif			

EXHIBIT C

LICENSE RECORDATION FORM

This License Recordation Form is a non-confidential statement of the Patent License Agreement ("Agreement") entered into and effective on June 9, 2009, by and between INNOVATECH, LLC ("Innovatech"), an Illinois limited liability company having its principal offices at 233 E. Wacker Dr., #4713, Chicago, Illinois, 60601, and ORION INDUSTRIES, LTD ("Orion"), an Illinois corporation having its principal offices at 5170 N. Northwest Highway, Chicago, Illinois, 60630.

For the purpose of recording the licenses provided in the Agreement, Innovatech and Orion acknowledge that under the Agreement:

Innovatech has granted Orion a non-exclusive license in certain fields of use under the following United States patents and United States Patent applications:

Coating Reinforcing Underlayment/Anti-Microbial Electrosurgical Electrode Patent Family

U.S. Patent Application Serial No. 10/318,503, filed on December 12, 2002, Docket No. 6491800-111 and entitled: COATING REINFORCING UNDERLAYMENT AND METHOD OF MANUFACTURING SAME;

U.S. Patent Application Serial No. 11/157,001, filed on June 20, 2005, Docket No. 6491800-127 and entitled: COATING REINFORCING UNDERLAYMENT AND METHOD OF MANUFACTURING SAME, which issued as U.S. Patent No. 7,261,925 on August 28, 2007;

U.S. Patent Application Serial No. 11/844,708, filed on August 24, 2007, Docket No. 6491800-143 and entitled: COATING REINFORCING UNDERLAYMENT AND METHOD OF MANUFACTURING SAME;

U.S. Patent Application Serial No. 10/649,199, filed on August 27, 2003, Docket No. 6491800-114 and entitled: ANTI-MICROBIAL ELECTROSURGICAL ELECTRODE AND METHOD OF MANUFACTURING THE SAME, which issued as U.S. Patent No. 7,160,297 on January 9, 2007;

U.S. Patent Application Serial No. 11/615,380, filed on December 22, 2006, Docket No. 6491800-139 and entitled: ANTI-MICROBIAL ELECTROSURGICAL ELECTRODE AND METHOD OF MANUFACTURING SAME, which issued as U.S. Patent No. 7,390,326 on June 24, 2008;

U.S. Patent Application Serial No. 11/615,395, filed on December 22, 2006, Docket No. 6491800-140 and entitled: ANTI-MICROBIAL ELECTROSURGICAL ELECTRODE AND

METHOD OF MANUFACTURING SAME, which issued as U.S. Patent No. 7,288,091 on October 30, 2007; and

U.S. Patent Application Serial No. 11/925,341, filed on October 26, 2007, Docket No. 6491800-144 and entitled: ANTI-MICROBIAL ELECTROSURGICAL ELECTRODE AND METHOD OF MANUFACTURING SAME.

Modified Rigid Silicone Electrode Patent Family

U.S. Patent Application Serial No. 11/127,545, filed on May 12, 2005, Docket No. 6491800-126, and entitled: ELECTROSURGICAL ELECTRODE AND METHOD OF MANUFACTURING SAME, which issued as U.S. Patent No. 7,147,634 on December 12, 2006;

U.S. Patent Application Serial No. 11/330,499, filed on January 11, 2006, Docket No. 6491800-128 and entitled: ELECTROSURGICAL ELECTRODE AND METHOD OF MANUFACTURING SAME;

U.S. Patent Application Serial No. 11/637,445, filed on December 11, 2006, Docket No. 6491800-138 and entitled: ELECTROSURGICAL ELECTRODE AND METHOD OF MANUFACTURING SAME; and

U.S. Patent Application Serial No. 11/637,446, filed on December 11, 2006, Docket No. 6491800-137 and entitled: ELECTROSURGICAL ELECTRODE AND METHOD OF MANUFACTURING SAME.

Coated Glass Patent Family

U.S. Patent Application Serial No. 10/186,368, filed on June 27, 2002, Docket No. 6491800-110 and entitled: METHOD OF MANUFACTURING PERFLUOROALKOXY COPOLYMER COATED GLASS, which issued as U.S. Patent No. 6,884,459 on April 26, 2005; and

U.S. Patent Application Serial No. 11/107,234, filed on April 15, 2005, Docket No. 6491800-121 and entitled: METHOD OF MANUFACTURING TETRAFLUORETHYLENE PERFLUOROMETHYL VINYL ETHER COPOLYMER COATED GLASS, which issued as U.S. Patent No. 7,488,511 on February 10, 2009.

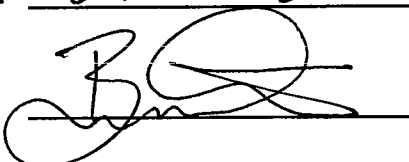
1. The other terms of the Agreement are confidential.

IN WITNESS WHEREOF, the parties hereto acknowledge that they have read the Agreement, fully understand it, and have freely and voluntarily entered into it.

INNOVATECH:

INNOVATECH, LLC

Print Name: Bruce Nesbitt

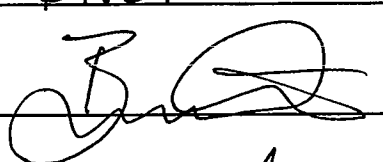
Signature: 

Title: MANAGER

ORION:

ORION INDUSTRIES, LTD

Print Name: Bruce Nesbitt

Signature: 

Title: President